

<b>INFORMATION DISCLOSURE CITATION FORM FOR PATENT APPLICATION (FORM PTO-1449) (Substitute)</b>	Docket No.: 875.0129.U1(US)      Serial No.:  Applicant(s): Lassi Hyvonen  Filing Date: herewith      Group:
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**U.S. PATENT DOCUMENTS**

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Examiner's Signature:

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